

APPLICANT'S ART CITATION <small>(Use several sheets if necessary)</small>		Application 10/585,289		OFGS File No. P/2850-144		
		Applicant Takeshi Nakamura				
		Filing Date July 7, 2006		Group Art Unit 1755		
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
	Document Number	Date MM-YYYY	Name	Class	Sub-class	
/CT/	US-6,838,162 B1	01-2005	GRUBER ET AL.			
/CT/	US-2003/0008067 A1	01-2003	YAMAGUCHI ET AL.			
	US-					
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FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Translation	
					Yes	No
/CT/	CN 1288874	09-2000	CHINA		U.S.P 6,838,162	
/CT/	JP 2003-20287	01-2003	JAPAN		U.S. PUB. 2003/0008067	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
/CT/	Office Action issued November 30, 2007 in corresponding Chinese Application No. 200480039952.9 and an English translation					
Examiner /Camie Thompson/		Date Considered		04/07/2008		
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